



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Steven A. Van Slyke, et al.

THERMAL PHYSICAL VAPOR DEPOSITION SOURCE FOR MAKING AN ORGANIC LIGHT-EMITTING DEVICE

Serial No. US 09/996,415

Filed 28 November 2001

Commissioner for Patents Washington, D.C. 20231

Sir:

Group Art Unit 1763 Examiner Richard R. Bueker

I hereby certify that this correspondence is being deposited today with the United States Postal Service as first class mail in an envelope addressed to Configuissioner for Patents, Washington, D.C. 20231.

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Date: April 23, 2002

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RESPONSE

In response to the Office Action mailed February 13, 2002, please reconsider the rejection of the above-identified application, without prejudice, in view of the following remarks.